

**Notice of References Cited**

Application/Control No.

09/884,467

Applicant(s)/Patent Under  
Reexamination  
BEDELL ET AL.

Examiner

Luke S. Wassum

Art Unit

2167

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0046204 A1	04-2002	Hayes, Scott R.	707/1
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	IBM "OS/390 Resource Measurement Facility Report Analysis", document SC28-1950-05, 6 <sup>th</sup> Edition, September 2000, pp. 1-1 through 1-7, 2-240 through 2-262, and 5-1 through 5-52.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.